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PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Eiji HASEGAWA

Serial No. 09/883,373

Filed June 19, 2001

SEMICONDUCTOR DEVICE HAVING A PLURALITY OF GATE INSULATING FILMS OF DIFFERENT THICKNESSES, AND METHOD FO MANUFACTURING SUCH SEMICONDUCTOR DEVICE Confirmation 1

GROUP 2823

Examiner N. Berezyn

<u>AMENDMENT</u>

Commissioner for Patents

Washington, D.C. 20231

Sir:

Responsive to the Official Action of August 13, 2002, please amend the above-identified application as follows.

Cancel claims 10-12.

REMARKS

Responsive to the requirement for restriction, applicant elects Group I, claims 1-9, drawn to the method, without traverse.

Non-elected claims 10-12 are cancelled herewith, but may be made the subject of a divisional application to be filed at any time during the pendency of the present application.